

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	294142	(insulat\$4 near10 form\$3) same layer	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 07:52
L2	29944	(conduct\$4 near10 layer\$1) same (IC or chip)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 07:53
L3	15279	(insulat\$4 near10 form\$3) same layer same (IC or chip)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 07:53
L4	5772	I2 and I3	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 07:52
L5	25426	(conduct\$4 near5 layer\$1) same (IC or chip)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 07:54
L6	12336	(insulat\$4 near5 form\$3) same layer same (IC or chip)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 07:54
L7	4214	I5 and I6	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 07:53
L8	5776	(insulat\$4 near5 form\$3) near50 layer near50 (IC or chip)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 07:54

L9	13873	(conduct\$4 near5 layer\$1) near40 (IC or chip)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 07:54
L10	1755	l8 and l9	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 07:54
L11	39	l10 and (implant\$4 near5 ion\$1)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 08:04
L12	52	2a same 3 same 2b same insulat\$4 same layer\$1 same hole\$1	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 07:57
L13	2553	polyimide near5 carbon	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 08:06
L14	378	polyimide near10 made near10 carbon	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 08:06
L15	169	polyimide near5 made near5 carbon	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 08:08
L16	2722	(conductive adj1 layer\$1) near10 carbon	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 08:08

L17	8	l16 and "235"/\$.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 08:08
L18	2364	(conductive adj1 layer) near20 nm	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 09:12
L19	380	si near40 dop\$4 near40 impurity near40 ion\$1	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 09:05
L20	2273	(si or silicon) near40 dop\$4 near40 impurity near40 ion\$1	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 09:05
L21	26	l20 and l18	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 09:05
L22	152	(conductive adj1 layer) same nm same silicon\$1 same ion\$1	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 10:41
L23	5	l21 and l22	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 09:47
L24	2	"6641050".pn.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 09:47

L25	147	I22 not I21	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 10:23
L26	1685	(conductive adj1 layer) near20 nm near20 thickness	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 10:50
L27	2592	(conductive adj1 layer) near25 silicon\$1 near40 (doped or impur\$4)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 10:44
L28	261	I26 and I27	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 10:49
L32	80312	("1" or "2" or "3" or "4" or "5" or "6" or "7" or "8" or "9") adj1 nm	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 10:54
L33	808	I26 and I32	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 10:54
L34	124	I33 and I27	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 13:03
L35	1	("6315195").PN.	US-PGPUB; USPAT	OR	OFF	2005/09/14 13:38
L36	0	(((((conductiveadj1layer\$1)same(("1"o r"2"or"3"or"4"or"5")adj1nm))and(") or ("goldorptorplati\$4orau")))).PN.	US-PGPUB; USPAT	OR	OFF	2005/09/14 13:45

L37	529	((conductive adj1 layer\$1) same (("1" or "2" or "3" or "4" or "5") adj1 nm)) and (gold or pt or plati\$4 or au)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 13:51
L38	136	((conductive adj1 layer\$1) same (("1" or "2" or "3" or "4" or "5") adj1 nm)) same (gold or pt or plati\$4 or au)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	OFF	2005/09/14 14:10